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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CON of PCT/JP02/08349 08/19/2002

yres 5.A

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2001-251421 08/22/2001

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## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	Examiner's Signature - Initials	JAPAN	14	43	7

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## TITLE

Method and device for simulation, method and device for polishing, method and device for preparing control parameters or control program, polishing system, recording medium, and method of manufacturing semiconductor device

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees
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